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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: K. YOSHIOKA, et al.

Serial No.: 10/083,353

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For: APPARATUS FOR PROCESSING SPECIMENS

Group: 1763

Examiner: K. Moore

LETTER TO THE OFFICIAL DRAFTSMAN

Commissioner for Patents  
Washington, D.C. 20231

February 3, 2003

Sir:

Concurrent with the response filed on February 3, 2003, Applicants submit corrected drawings of Figures 1, 2, 9, 10 and 12. The corrected drawings contain corrections similar to those that were made in the parent application, Serial No. 09/493,104. In particular, in Figures 1 and 2, the "etching chamber 1" is designated as the "etching process unit 1". In Figure 1, the "unload lock chamber" is designated with reference numeral "4" instead of "7". In Figure 9, in S12, the reference number "41" is changed to "51"; in S13, the spelling of "etching" has been corrected; In D12, D13 and D14 a clear demarcation is given for the seed layer 44 consistent with what is shown in D15 and D16 and layer 44 is clearly shown and labeled. Spelling errors are corrected in Figures 10 and 12. It is respectfully submitted that no new matter is introduced by these corrected drawings.

Respectfully submitted,

ANTONELLI, TERRY, STOUT & KRAUS, LLP

By

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Attachment: Drawings (4 sheets)  
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